



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1762

Application No.: 10/827,317

Examiner: J. LIN

Filed: April 20, 2004

Docket No.: 119294

For: PATTERN FORMATION METHOD, DEVICE MANUFACTURING METHOD,  
ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the May 16, 2007 Office Action, and after entry of the attached Request for Continued Examination, reconsideration of the rejections is respectfully requested in light of the following remarks.